

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yixiang Duan

Docket No.: S-100,580

Serial No.:

Examiner:

Filed :

Art Unit:

For : LOW-POWER ATMOSPHERIC PRESSURE MINI-PLASMA AND
ARRAY FOR SURFACE AND MATERIAL TREATMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.56, 1.97, AND 1.98

Sir:

The documents listed below, copies attached, are submitted in compliance with the duty of disclosure defined in 37 CFR 1.56.

CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8(a))

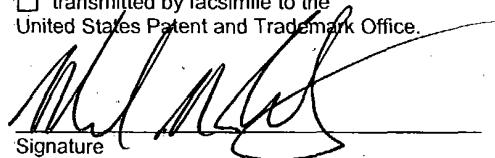
I hereby certify that this correspondence is, on the date shown below, being:

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Signature

Date July 9, 2003

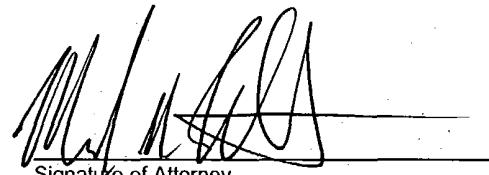
Mark N. Fitzgerald
(type or print name of person certifying)

1. Selywn, "Atmospheric-pressure plasma jet," U.S. Pat. No. 5,961,772, issued October 5, 1999
2. Roth et al., "One Atmosphere, Uniform Glow Discharge Plasma," U.S. Patent No. 5,414,324, issued May 9, 1995
3. Roth et al., "Method And Apparatus For Glow Discharge Plasma Treatment Of Polymer Materials At Atmospheric Pressure", U.S. Patent No. 5,456,972, issued October 10, 1995.

This Information Disclosure Statement is not to be construed as a representation that a search has been made or that additional matter material to the examination of this application does not exist. Applicant does not believe that any of these citations constitutes prior art under 35 U.S.C. 102.

It is requested that the above citations be made of record in the prosecution of this application.

Respectfully submitted,



A handwritten signature in black ink, appearing to read "Mark N. Fitzgerald". Below the signature is a horizontal line.

Signature of Attorney

Date: July 9, 2003

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Sheet 1 of 1

Form PTO-1449 U.S. Department of Commerce (Modified) Patent and Trademark Office								Attorney Docket No.	Serial No.			
								S-100,580				
								Applicant(s) Yixiang Duan				
								Filing Date	Group			
37 CFR 1.98(b)												
U.S. PATENTS DOCUMENTS												
EXAMINER INITIAL	PATENT NUMBER							ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	5	9	6	1	7	7	2	12/5/99	Selywn	156	345.39	January 23, 1997
	5	4	1	4	3	2	4	5/9/95	Roth et al.	315	111.21	October 29, 1993
	5	4	5	6	9	7	2	10/10/95	Roth et al.	442	301	May 28, 1993
FOREIGN PATENT DOCUMENTS												
EXAMINER INITIAL	PATENT NUMBER							ISSUE DATE	COUNTRY	CLASS	SUB CLASS	Translation YES NO
OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)												
EXAMINER:								DATE CONSIDERED:				
*EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.												